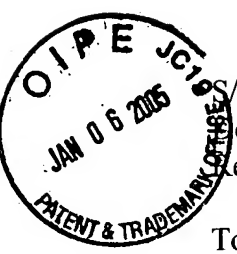


IFW



S/N: 10/ 768,612
Docket: CS03-048
Reply to the Office action dated Dec. 28, 2004

To: Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

5 From: William J. Stoffel 1735 Market St - Ste A
Reg no. 39,390 PMB 455
Customer no. 30,402 Philadelphia, PA 19103 USA

10 Subject:

S/N: 10/ 768,612
Docket: CS03-048
Reply to the Office action dated Dec. 28, 2004
File date: 1/30/04
Inventor: Yisuo Li
Title : **A SEMICONDUCTOR DEVICE LAYOUT AND
CHANNELING IMPLANT PROCESS**

Group Art Unit: 2812
Examiner: Lindsay Jr., Walter Lee

RESPONSE TO PATENT OFFICE ACTION

15 Dear Sir:

In response to the office action dated 12 /28 /2004, please consider the following remarks:

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being :

20 ☐ FAXED to the central facsimile number of patent and trademark office at the following number 703) 872-9306 or
☒ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 4, 2005.

25 Signature/Date William J. Stoffel 1/4/05 January 4, 2005.
William J. Stoffel Reg. No. 39,390 Customer number 30402

This response to Office Action has the following sections:

- **Amendments to the claims** begin the next page of this paper
- **Remarks/Arguments** begin on the page following the amendments to the claims.